

	Hit s	Search Text	DBs
47	97	((substrate or wafer) same (LCD or panel\$3 or unit or intaglio or clich\$2 or area or region or divid\$3) same pattern\$4) and (LCD same (gate near4 line) same (pluralit\$4 or multiple) same (data near4 line) same ((pluralit\$5 or multiple) near14 pixel) same (pixel near12 electrode) same transistor) and (print\$4)	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB
48	1	(LCD same (gate near4 line) same (pluralit\$4 or multiple) same (data near4 line) same ((pluralit\$5 or multiple) near14 pixel) same (pixel near12 electrode) same transistor) and (((printing adj (roll or cylinder))) same (pattern or resist or photoresist))	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB

	Hit s	Search Text	DBs
49	1	(LCD same (gate near4 line) same ((pluralit\$5 or multiple) near14 pixel) same (pixel near12 electrode) same transistor) and (((printing adj (roll or cylinder))) same (pattern or resist or photoresist))	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB
50	12	(LCD same (gate near4 line) same pixel same (pixel near12 electrode) same transistor) and (((printing adj (roll or cylinder))) same (pattern or resist or photoresist))	US-PGPUB; USPAT; FPRS; EPO; JPO; DERWENT; IBM_TDB